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## BIB DATA SHEET

CONFIRMATION NO. 2644

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/531,125	04/13/2006	438	1793	PI-128
RULE				
<b>APPLICANTS</b> Hyun Soo Roh, Kyoungi-Do, KOREA, REPUBLIC OF; Tae Won Park, Kyoungi-Do, KOREA, REPUBLIC OF; Kill Sung Lee, Kyoungi-Do, KOREA, REPUBLIC OF; In Kyung Lee, Kyoungi-Do, KOREA, REPUBLIC OF;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/KR03/01532 07/30/2003				
<b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 10-2002-0077860 12/09/2002				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 07/22/2006				
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b>	<b>SHEETS DRAWINGS</b>
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		KOREA, REPUBLIC OF	0
Verified and	/MICHAEL A MARCHESCHI/	Initials		
Acknowledged	Examiner's Signature			
<b>INDEPENDENT CLAIMS</b> 1				
<b>TOTAL CLAIMS</b> 6				
<b>ADDRESS</b> SALIWANCHIK LLOYD & SALIWANCHIK A PROFESSIONAL ASSOCIATION PO BOX 142950 GAINESVILLE, FL 32614-2950 UNITED STATES				
<b>TITLE</b> Slurry composition for secondary polishing of silicon wafer				
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees	
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